



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 9011

Toshiharu TANAKA et al.

Group Art Unit: 2881

Application No.: 10/820,732

Examiner: Phillip A. JOHNSTON

Filed: April 9, 2004

Attorney Dkt. No.: 107350-00008

For: SUBSTRATE PROCESSING APPARATUS AND MAINTENANCE METHOD
THEREFOR

RESPONSE UNDER 37 C.F.R. § 1.121

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Date: March 28, 2007

Sir:

This paper is In reply to the Office Action dated December 29, 2006.

Amendments to the **Claims** begin on page 2.

Remarks begin on page 5.